

Broadband antireflection nanodome structures on SiC substrate - DTU Orbit (09/11/2017)

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Nanodome structures are demonstrated on the SiC substrate by using nanosphere lithography and dry etching. Significant surface antireflection has been observed over a broad spectral range from 400 nm to 1600 nm.

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Authors: Ou, Y. (Intern), Zhu, X. (Intern), Møller, U. V. (Intern), Xiao, S. (Intern), Ou, H. (Intern)

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